



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seidl, et al. Attorney Docket: INF-130
Filed: January 28, 2004 Examiner: TBD
Serial No.: 10/765,052 Art Unit: 2812
For: Method of Fabricating an Oxide Collar for a Trench Capacitor

Mail Stop: Amendment
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Respectfully submitted,

Ira S. Matsil
Attorney for Applicants
Reg. No. 35,272

October 14, 2004
Date

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Respectfully submitted,

A handwritten signature in black ink that reads "Natalie Swider".

Natalie Swider
Legal Assistant

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PTO/SB/08a (08-03)

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| Substitute for form 1449A/PTO | | <i>Complete if Known</i> | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i> | | Application Number | 10/765,052 |
| | | Filing Date | 1/28/2004 |
| | | First Named Inventor | Seidl, et al. |
| | | Art Unit | 2812 |
| | | Examiner Name | TBD |
| Sheet | 1 | of | 1 |
| | | Attorney Docket Number | INF-130 |

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
|--------------------|----------|---|----------------|
| | 3 | KLAUS, J.W., et al., "Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions," <i>Surface Review and Letters</i> , Vol. 6, Nos. 3 & 4 (1999) pp. 435-448. | |
| | 4 | KLAUS, J.W., et al., "Growth of SiO ₂ at Room Temperature with the Use of Catalyzed Sequential Half-Reactions," Department of Chemistry and Biochemistry, University of Colorado, Boulder, CO (1997). | |
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| Examiner Signature | | Date Considered | |
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